



● Poster Sessions

[P1] Poster Session 1

Session Date	Oct. 17(Thu.), 2024
Session Time	09:00-10:30
Session Room	Room B (Vernazza, 3F)

[P1-001]

Double Passivation Effect of AlGaInP Based Red Micro-LEDs

Seung-Hyun Mun, Je-Sung Lee, Soo-Young Choi, Jaeyoung Baik, Jin-Soo Kim, Jeongwoon Kim, Seung-Hyeok Lee, and Dong-Seon Lee

Gwangju Institute of Science and Technology, Korea

[P1-002]

Efficiency Improvement of InGaN-Based Micro-LEDs via Indium Tin Oxide p-Electrodes

Cesur Altinkaya, Daisuke Iida, and Kazuhiro Ohkawa

King Abdullah University of Science and Technology (KAUST), Saudi Arabia

[P1-003]

Acetylenic Coupling on Cupric Oxide Photocathode for Accelerating Solar-to-Hydrogen Conversion

Hoki Son, Periyayya Uthirakumar, and In-Hwan Lee

Korea University, Korea

[P1-004]

Integration of Multiple Blue InGaN/GaN Microrod-LED Alignment Using Dielectrophoresis with Flexible Substrate

Pil-Kyu Jang, Yeong-Hoon Cho, and In-Hwan Lee

Korea University, Korea

[P1-005]

AlGaInP Red Nanohole-Structure LED with Shaped Au/SiO₂ Nanoparticles for Localized Surface Plasmon

Sang-Bum Kim, Pil-Gyu Jang, and In-Hwan Lee

Korea University, Korea

[P1-006]**vdWE(van der Waals Epitaxy) of GaN on Amorphous Substrate through rGO (Reduced Graphene Oxide) Buffer by Sputtering**

Gyulim Kim, Hoki Son, and In-Hwan Lee
Korea University, Korea

[P1-007]**Achieving Vertical Alignment of InGaN/GaN Nanorod LEDs in Nanohole Electrodes via Dielectrophoresis**

Jiwon Park, Yeong-Hoon Cho, Pil-Kyu Jang, Sangbum Kim, Seungjae Baek, Taehwan Kim, and In-Hwan Lee
Korea University, Korea

[P1-008]**An Arrays of Blue InGaN/GaN Nano-LEDs Integrated with Localized Surface Plasmon of Ag/SiO₂ Nanoparticles**

Yeong-Hoon Cho, Seung-Jae Baek, Tae-Hwan Kim, Pil-Gyu Jang, Sang-Bum Kim, Ji-won Park, and In-Hwan Lee
Korea University, Korea

[P1-010]**Homogenous Metallization of Through-Glass Vias with Floating Plating based on the Synergistic Effect of Capillary Rise and van der Waals**

Changmin Yun, Hoki Son, and Inhwan Lee
Korea University, Korea

[P1-011]**New Solution Growth of AlN Single Crystals Using Fe-Cr Based Fluxes**

S. Li, M. Adachi, M. Ohtsuka, and H. Fukuyama
Tohoku University, Japan

[P1-012]**Improved Alignment of GaN Nanorod LEDs Using Insulator-Based Dielectrophoresis**

Yeong-Hoon Cho and In-Hwan Lee
Korea University, Korea



[P1-013]

Improved Carrier Confinement in Small-Sized Green Micro-LEDs

A. B. M. H. Islam¹, T. K. Kim², J. Bae³, Y.-J. Cha¹, H. Lee¹, C. Park¹, J. Oh¹, M. Kim¹, I. Choi³, J. W. Seo¹, D.-P. Han⁴, J. O. Song², D.-S. Shin³, J.-I. Shim³, and J. S. Kwak¹

¹Korea Institute of Energy Technology, Korea, ²Wavelord Co., Ltd., Korea, ³Hanyang University, Korea,

⁴Pukyong National University, Korea

[P1-014]

Spectral Imaging Analysis of InGaN Quantum Wells Using Tensor Decomposition

Kazunori Iwamitsu¹, Kenta Sakai², Zentaro Akase¹, Atsushi A. Yamaguchi², and Shigetaka Tomiya¹

¹Nara Institute of Science and Technology, Japan, ²Kanazawa Institute of Technology, Japan

[P1-015]

Analysis of Thermal Dynamics due to Luminescence of GaN-Based Micro LEDs Using Optical Methods

Jung-ki Park¹, Jae-sun Kim¹, Gyeongun Choi¹, Kyung-rok Kim¹, Hye-jun Yun¹, Sung-min Hwang², Won Taeg Lim², Seoungyoung Lim³, and Jung Hoon Song^{1,3}

¹Kongju National University, Korea, ²Soft-EPI, Korea, ³Accu Optotec, Korea

[P1-016]

Strain Profiling and Temperature Dependence of Single-Photon Emitter in GaN

Gyeong Eun Choi¹, Jae Sun Kim¹, Jung Ki Park¹, Kyung Rok Kim¹, Hye Jun Yun¹, Seong Young Lim², and Jung-Hoon Song^{1,2}

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[P1-017]

Enhancing Optical Performance of Flat-Type GaN-Based Light-Emitting Diodes via Multiple Local Breakdown Conductive Channels

Dae-Choul. Choi, Seung Hun. Lee, and Sung-Nam. Lee

Tech University of Korea, Korea

[P1-019]

Integrating Circadian and Visual Benefits in LED Lighting with RGBYW Channels

Lvyun Chen¹, Zhizhong Chen¹, Zhuoyao Ma², Qihong Zhou¹, Lun Song², Zhuojian Pan¹, Chuhan Deng¹, Haodong Zhang¹, Boyan Dong¹, Yiran Wu¹, and Fei Jiao¹

¹Peking University, China, ²Beijing Institute of Basic Medical Sciences, China

[P1-020]

Effect of Cooling Rate on Solution Growth of AlN Crystal Using Fe-Cr-Ni Flux

Makoto Ohtsuka, Go Shinnoda, Masayoshi Adachi, and Hiroyuki Fukuyama

Tohoku University, Japan

[P1-021]

Examining the Influence of Growth Temperature on n-AlGaIn Buffer Layer and Quantum-Well of (228-230 nm)-Band far-UVC LEDs

M. Ajmal Khan¹, Mitsuhiro Muta², Hiroyuki Oogami², Kohei Fujimoto^{1,3}, Yuya Nagata^{1,3}, Yukio Kashima¹, Eriko Matsuura¹, Hiroyuki Yaguchi³, Yasushi Iwaisako², and Hideki Hirayama¹

¹RIKEN Cluster for Pioneering Research (CPR), Japan, ²Nippon Tungsten Co., Ltd., Japan, ³Saitama University, Japan

[P1-022]

Synthesis of AlN Crystals by Solution Growth Method Using Fe-Cr-Ni Fluxes

Go Shinnoda, Masayoshi Adachi, Makoto Ohtsuka, and Hiroyuki Fukuyama

Tohoku University, Japan

[P1-023]

An Approach to Enhancing Deep Ultraviolet Luminescence by a Combinatorial Semipolar AlGaIn Quantum Well Structures

Ge Gao, Li Chen, Wei Guo, and Jichun Ye

Chinese Academy of Sciences, China

[P1-024]

Selective Area Regrowth and Characterization of GaN by Hydride Vapor Phase Epitaxy

Hyojung Bae¹, Hae-Gon Oh², Young-Jun Choi², Hae-Yong Lee², and Jin-Woo Ju¹

¹Korea Photonics Technology Institute, Korea, ²LumiGNtech Co., Ltd., Korea

[P1-025]

The Multi-Color MicroLED Technology with High-Pixel Density Implemented through Selectively Lateral Growth Method

Hyung-Gu Kim¹, Chang-Mo Kang², Jun-Beom Park¹, Sang-Hoon Han¹, In-Seong Cho³, and Tak Jeong¹

¹Korea Photonics Technology Institute, Korea, ²Pusan National University, Korea, ³Soft-EPi, Korea



[P1-026]

Low-Temperature Buffer Growth of GaN on Graphene for Exfoliable Micro-Pyramidal GaN Structures

Jeongho Kim, Baul Kim, and Yong-Hoon Cho

Korea Advanced Institute of Science and Technology, Korea

[P1-027]

Etching-Free Fabrication of Sub-Micron Light-Emitting Diode Pixel Arrays by Helium Ion Irradiation

Ji-Hwan Moon, Baul Kim, Minhoo Choi, Kie Young Woo, Byung Su Kim, Seonghun Ahn, Seongmoon Jun, Yong-Ho Song, and Yong-Hoon Cho

Korea Advanced Institute of Science and Technology, Korea

[P1-028]

Active-Layer Characteristics of Eu-Doped GaN-Based Red Light-Emitting Diodes Investigated by Photoexcitation Measurements

Ilgyu Choi¹, Sangjin Min¹, Dong-Soo Shin¹, Yasufumi Fujiwara², and Jong-In Shim¹

¹Hanyang University, Korea, ²Ritsumeikan University, Japan

[P1-029]

Pure Single-Photon Emission from InGaN Quantum Dot Embedded in a GaN Nanowire Using Focused-Ion-Beam Induced Luminescence Quenching Method

Yubin Je¹, Seongmoon Jun¹, Neul Ha¹, Noelle Gogneau², and Yong-Hoon Cho¹

¹Korea Advanced Institute of Science and Technology, Korea, ²French National Centre for Scientific Research, France

[P1-030]

Indium-Rich InGaN/GaN Multi Quantum Wells Red LEDs

Joonghoong Choi, Won Kwang Yang, and Young Joon Hong

Sungkyunkwan University, Korea

[P1-031]

Fabrication of GaN Nanorods Using Metal-Assisted Photochemical Etching Technique

ChangSoo Kim and Young Joon Hong

Sungkyunkwan University, Korea

[P1-032]**High-Efficiency Color Conversion Films based on Three-Dimensional Photonic Crystals**

Taehun Kim and Kyungtaek Min

*Tech University of Korea, Korea***[P1-033]****Integrated Micro LEDs with Optoelectronic Synapses for Implement Neuromorphic Device**Y.-J. Cha¹, T. K. Kim², J. Oh¹, H. Lee¹, M. Kim¹, C. Park¹, J. W. Seo¹, A. B. M. H. Islam¹, S. W. Cho³, and J. S. Kwak¹¹Korea Institute of Energy Technology, Korea, ²Wavelord Inc., Korea, ³Sunchon National University, Korea**[P1-034]****Optical Characteristics of InGaN-Based Red μ LED by Changing the Structure of the Emitting Area at 400 μm^2** Sungoh Cho¹, Jung-Hong Min¹, Sung Hoon Jung¹, Shang Hern Lee¹, Hwa Sub Oh¹, and Tae-Hoon Chung^{1,2}¹Korea Photonics Technology Institute, Korea, ²Chonnam National University, Korea**[P1-035]****Investigated Aging Test of Red/Green Micro-LEDs**

Hsin-Ying Lee, Yan-Zhang Chen, Mu-Ju Wu, and Ching-Ting Lee

*National Cheng Kung University, Taiwan***[P1-036]****Emission Color Control of InGaN/GaN Nanocolumn Arrays on Si Substrates Grown via Nanotemplate Selective Area Growth**

Kota Hoshino, Rie Togashi, and Katsumi Kishinio

*Sophia University, Japan***[P1-037]****Fabrication of InGaN-Based Vertical Blue Laser Diodes with p-Contact Formed by Chemical Wet Etching**J. W. Seo¹, A. B. M. H. Islam¹, Y.-J. Cha¹, H. Lee¹, C. Park¹, J. Oh¹, M. Kim¹, S. R. Jeon², and J. S. Kwak¹¹Korea Institute of Energy Technology, Korea, ²Korea Photonics Technology Institute, Korea



[P1-038]

Structural Characteristics and Optical Properties of Nanoporous GaN for Quantum Dot Embedding

Jaeyoung Baik, Jeongwoon Kim, Je-Seng Lee, Jin-Soo Kim, and Dong-Seon Lee

Gwangju Institute of Science and Technology, Korea

[P1-039]

Stimulated Emission at 247 nm From AlGaIn/AlN Multiple Quantum Wells on 4H-SiC Substrates

Yanan Guo^{1,2}, Ruijie Zhang^{1,2}, Han Wu^{1,2}, Zhibin Liu^{1,2}, Jianchang Yan^{1,2,3}, Jinmin Li^{1,2,3}, and Junxi Wang^{1,2}

¹Chinese Academy of Sciences, China, ²University of Chinese Academy of Sciences, China, ³Advanced Ultraviolet Optoelectronics Co., Ltd., China

[P1-040]

Analysis of AlGaInP-Based Red Micro Light-Emitting Diodes with Different Quantum-Well Structure

Soo-Young Choi, Seung-Hyun Mun, Je-Sung Lee, and Dong-Seon Lee

Gwangju Institute of Science and Technology, Korea

[P1-042]

Low-Threshold UV-B Laser Diode With Short-Period Superlattice Upper Waveguide Layer

Rui Ren^{1,2}, Yanan Guo^{1,2}, Zhibin Liu^{1,2}, Jinmin Li^{1,2,3}, Junxi Wang^{1,2}, and Jianchang Yan^{1,2,3}

¹Chinese Academy of Sciences, China, ²University of Chinese Academy of Sciences, China, ³Advanced Ultraviolet Optoelectronics Co., Ltd., China

[P1-043]

Epitaxial Growth of GaN on Glass Substrates via Electron Beam Assisted Sputtering

C. Park, Y.-J. Cha, A. B. M. H. Islam, J. Oh, M. Kim, H. Lee, J. Seo, and J. S. Kwak

Korea Institute of Energy Technology, Korea

[P1-044]

Nano-Engineered InGaIn Micro-LEDs towards Chip-to-Chip Interconnections

Zhenhao Li¹, Zengyi Xu², Xianhao Lin², Xinran Zhang¹, Luming Yu¹, Bo Liu¹, Zhibiao Hao¹, Yi Luo¹, Changzheng Sun¹, Bing Xiong¹, Yanjun Han¹, Jian Wang¹, Hongtao Li¹, Lin Gan¹, Nan Chi², and Lai Wang¹

¹Tsinghua University, China, ²Fudan University, China

[P1-045]

Exciton-Polariton Condensate in Gallium Nitride Superscar Mode Cavity at Room TemperatureChan Young Sung¹, Hyun Gyu Song², and Yong Hoon Cho¹¹Korea Advanced Institute of Science and Technology, Korea, ²Korea Institute of Science and Technology, Korea

[P1-047]

Micro-Photoluminescence Spectroscopy of InGaN Quantum Wells on Convex Lens-Shaped GaN Microstructures

Akitoshi Takahama, Yoshinobu Matsuda, Mitsuru Funato, and Yoichi Kawakami

Kyoto University, Japan

[P1-048]

Investigation on Mg Diffusion in InGaN LED Studied by Deep-Level Transient Spectroscopy and Thermal Admittance SpectroscopyBo Liu¹, Zilan Wang², Haoyang Li², Zhibiao Hao¹, Yi Luo¹, Changzheng Sun¹, Bing Xiong¹, Yanjun Han¹, Jian Wang¹, Hongtao Li¹, Lin Gan¹, and Lai Wang¹¹Tsinghua University, China, ²Dalian University of Technology, China

[P1-049]

Structural and Optical Properties of Strain-Stress Relaxed InGaN-Based Micro LED on Nanoporous GaN Double Layer

Sang-Ik Lee, Hoki Son, and In-Hwan Lee

Korea University, Korea

[P1-050]

Excitation Spot Size Dependence of Photonic and Exciton Polaritonic Modes in a GaN MicrowireGwang Kim¹, Hyun Gyu Song², and Yong Hoon Cho¹¹Korea Advanced Institute of Science and Technology, Korea, ²Korea Institute of Science and Technology, Korea

[P1-051]

Homoepitaxial Growth on *a*-Plane AlN Template by HVPE

Shunki Ito, Ryota Akaike, Hiroki Yasunaga, Takao Nakamura, and Hideo Miyake

Mie University, Japan



[P1-052]

Electron Beam-Excited Light Source Emitting at 230 nm Using AlGaIn/AlN Multiple Quantum Wells

Ryoya Iwase¹, Ryota Akaike¹, Hiroki Yasunaga¹, Takao Nakamura¹, Masayoshi Nagao², Katsuhisa Murakami², and Hideto Miyake¹

¹Mei University, Japan, ²National Institute of Advanced Industrial Science and Technology, Japan

[P1-053]

The Compositd High Reflectivity P-type Electrodes with Patterned ITO for AlGaIn-Based Ultraviolet Light Emitting Diodes

Jing Lang, Fujun Xu, Jiaming Wang, Chen Ji, Weikun Ge, and Bo Shen

Peking University, China

[P1-054]

GaInN/GaN Multi Quantum Shell (MQS) Nano Pyramid with a GaInN Layer

Yuta Hattori¹, Weifang Lu², Kosei Kubota¹, Aoi Nakagawa¹, Naoto Hukami¹, Satoshi Kamiyama¹, Tetsuya Takeuchi¹, and Motoaki Iwaya¹

¹Meijo University, Japan, ²Xiamen University, China

[P1-055]

AlGaIn Quantum Wells Grown on Cubic Boron Nitride

Chen-Da Du¹, Ting-Hao Chang¹, Yun-Chorng Chang², and Kun-Yu Lai¹

¹National Central University, Taiwan, ²Research Center for Applied Sciences, Taiwan

[P1-056]

AlN/GaN Digital Alloys with High Average Al Compositions and DUV LEDs Grown by Molecular Beam Epitaxy

Siqi Li¹, Pengfei Shao¹, Xiao Liang¹, Songlin Chen¹, Xiaoquan Xing¹, Tao Tao¹, Zili Xie¹, Bin Liu¹, M. Ajmal Khan², Li Wang², T. T. Lin², Hideki Hirayama², Rong Zhang^{1,3}, and Ke Wang^{1,2}

¹Nanjing University, China, ²RIKEN, Japan, ³Xiamen University, China

[P1-057]

HfO₂-Based Memory Transistor for Driving Micro-LED Display

Sim Hun Yuk, Ho Jin Lee, Seok Hee Hong, Sung Keun Choi, and Tae Geun Kim

Korea University, Korea

[P1-058]**Growth of AlGaIn Channel HEMT with Superlattices by MOCVD**

Jooyong Park, Joocheol Jeong, Shyam Mohan, Joonhyuk Lee, Jaejin Heo, and Okhyun Nam
Tech University of Korea, Korea

[P1-059]**Study of Normally-Off p-GaN/p-AlGaIn Step Gate HEMT Grown on AlN/SiC**

Jaejin Heo, Joocheol Jeong, Shyam Mohan, Jooyong Park, Joonhyuk Lee, and Okhyun Nam
Tech University of Korea, Korea

[P1-060]**Unveiling the Potential of Pulsed Flow Growth Techniques to Realize the Al-Rich AlGaIn Channel HEMT**

Shyam Mohan, Joocheol Jeong, Jooyong Park, Joonhyuk Lee, Jaejin Heo, and Okhyun Nam
Tech University of Korea, Korea

[P1-061]**The Influence of Sapphire Substrate Low Angle Grain Boundaries on HVPE Growth of Gallium Nitride Crystal**

Yongliang Shao, Baoguo Zhang, Haixiao Hu, Xiaopeng Hao, and Yongzhong Wu
Qilu University of Technology, China

[P1-062]**Power and Thermal Stress Characterizations of AlGaIn/GaN HEMTs: A Comprehensive Study at Varying Elevated Temperatures**

Surajit Chakraborty and Roy Byung Kyu Chung
Kyungpook National University, Korea

[P1-063]**Gate Leakage Current Reduction for Blocking Voltage Improvement on GaN-on-Si HEMTs**

Chen-Hao Wu, Yi-Hong Chen, Yi-Wan Wang, and Yue-ming Hsin
National Central University, Taiwan



[P1-064]

XPS Analysis of Fe-Doped GaN Using First-Principles Calculations

Rina Yabuta and Masato Oda

Wakayama University, Japan

[P1-066]

A Study of the Initial Stage of Crystal Growth of NbN on AlN(0001) by First-Principles Calculation

Ryuji Nakagoshi and Masato Oda

Wakayama University, Japan

[P1-067]

Thermal Hot Spot and Its Dissipation to Substrate Investigated by Simultaneous Thermal Imaging of GaN Layer and Si Substrate in Power Device Structure

Jae Sun Kim¹, Gyeong Eun Choi¹, Jung Ki Park¹, Kyung Rok Kim¹, Hye Jun Yun¹, Seongyoung Lim², Deok Gyu Bae³, Young Boo Moon⁴, and Jung Hoon Song^{1,2}

¹Kongju National University, Korea, ²Accu Optotec, Korea, ³Hexasolution Co., Ltd., Korea, ⁴UJL Inc., Korea

[P1-068]

Small Signal Characteristics of AlGaIn/GaN Light-Emitting HEMTs

Yao-Luen Shen, Po-Chen Chen, and Chih-Fang Huang

National Tsing Hua University, Taiwan

[P1-069]

Enhancing Bonding Energy and High-Temperature Stability through Surface Activated Bonding with Al₂O₃ Auxiliary Layer

Xiangjie Xing^{1,2}, Hongze Zhang^{1,2}, Xinhua Wang^{1,2}, Fengwen Mu³, Sen Huang^{1,2}, Qimeng Jiang^{1,2}, Ke Wei^{1,2}, and Xinyu Liu^{1,2}

¹Institute of Microelectronics of Chinese Academy of Sciences, China, ²University of Chinese Academy of Sciences, China, ³Innovative Semiconductor Substrate Technology Co., Ltd., China

[P1-070]

Theoretical Study on Structural Stability and Polarization Switching of ScAlN Alloys: Effect of Lattice Constraints

Takuto Miyamoto, Toru Akiyama, and Takahiro Kawamura

Mie University, Japan

[P1-071]**High Electron Mobility of Exceeding 2000 cm²/Vs by Sharpening the AlGa_n/GaN Heterointerface Grown on Si Substrate**

Jumpei Tajima, Hajime Nago, Shinya Nunoue, and Toshiki Hikosaka
Toshiba Corporation, Japan

[P1-072]**Substrate Bias Induced V_{TH} and R_{ON} Instability in p-GaN HEMTs**

C. Feng, X. Liu, J. Wu, D. Mao, R. Du, Z. Cai, X. Zhang, N. Gong, Y. Shi, K. Wu, C. Li, X. Wang, H. Hu, W. Zeng, D. Zhou, and Y. Wan
Shenzhen Pinghu Laboratory, China

[P1-074]**Device-Level Thermal Management of Ultrawide Bandgap Al_xGa_{1-x}N Channel High Electron Mobility Transistors**

Jisu Kim, Jongwon Baek, Changhwan Song, and Jungwan Cho
Sungkyunkwan University, Korea

[P1-075]**Enhancing Breakdown Voltage of GaN HEMTs by Using a ZrO₂ Passivation Layer**

Sheng-Kai Chen¹, Zih-Jyun Hong¹, Yen-Feng Lu¹, Shao-Shing Hsue¹, Chang-Hong Shen², and Jen-Inn Chyi¹
¹National Central University, Taiwan, ²Taiwan Semiconductor Research Institute, Taiwan

[P1-076]**Growth and Characterization of Vertical GaN PIN Structures with Compositionally Graded AlGa_n Drift Layers**

Joocheol Jeong, Shyam Mohan, Jooyong Park, Joonhyuk Lee, Jaejin Heo, and Okhyun Nam
Tech University of Korea, Korea



[P1-077]

High Field Effect Mobility in Normally-Off O₂ Plasma-Treated GaN-Based MIS-HEMTs with Relatively Thick AlGaIn Barrier Layer

Kishi Sekiyama¹, Masaki Ishiguro¹, Ali Baratov¹, Shogo Maeda¹, Takahiro Igarashi¹, Suguru Terai¹, Akio Yamamoto¹, Masaaki Kuzuhara², Biplab Sarkar^{3,4}, Hiroshi Amano³, and Joel T. Asubar¹

¹University of Fukui, Japan, ²Kwansei Gakuin University, Japan, ³Nagoya University, Japan, ⁴Indian Institute of Technology, India

[P1-078]

A Novel Threshold Voltage Model for GaN Vertical Junctionless Fin-MOSFETs

Ankita Mukherjee, Smriti Singh, Tanmoy Pramanik, and Biplab Sarkar

Indian Institute of Technology Roorkee, India

[P1-079]

Enhancement of GaN Vertical Transistor Performance Through Trench Sidewall Treatment

Zhi-Xiang Zhang, Yu-Chuan Chu, Chih-Kang Chang, and Jian-Jang Huang

National Taiwan University, Taiwan

[P1-080]

Optimization and Characterization of P-type Gallium Nitride Contacts for High Power GaN Vertical Device Applications

Donghan Kim^{1,2}, Hongsik Park¹, Sung-Beum Bae², and Hyung-seok Lee²

¹Kyungpook National University, Korea, ²Electronics and Telecommunications Research Institute, Korea

[P1-081]

Quaternary InAlGaIn/GaN HEMTs with Oxygen Plasma Treatment

Juyeong Park¹ and Jae-Hyung Jang²

¹Gwangju Institute of Science and Technology, Korea, ²Naju Korea Institute of Energy Technology, Korea

[P1-082]

Optimizing GaN FinFET Fabrication via TMAH Wet Etching Techniques

Hyun-Woo Lee^{1,2}, Soo-Young Moon^{1,2}, Dong-Han Kim¹, Hyeon-Tak Kwak¹, Sang-Mo Koo², Sung-Bum Bae¹, and Hyung-Seok Lee¹

¹Electronics and Telecommunications Research Institute, Korea, ²Kwangju University, Korea

[P1-083]**Influence of Schottky Barrier as a Edge Termination Method and Effect based on Schottky Barrier Height**J. Oh¹, M. Kim¹, H. Lee¹, C. Park¹, Y.-J. Cha¹, J. W. Seo¹, A. B. M. H. Islam¹, J.Cho², and J. S. Kwak¹¹Korea Institute of Energy Technology, Korea, ²Jeonbuk National University, Korea**[P1-084]****Band Engineering of Polarization Induced 2D Hole Gases in GaN/AlGaIn Heterostructures**Pengfei Shao¹, Siqi Li¹, Hui Guo¹, Tao Tao¹, Zili Xie¹, Bin Liu¹, Dunjun Chen¹, Youdou Zheng¹, Rong Zhang¹, and Ke Wang^{1,2}¹Nanjing University, China, ²RIKEN, Japan**[P1-085]****The Effects of Different Oxidation Methods on GaN High Electron Mobility Transistors (HEMTs)**

Yu-Hsuan Lu, Chin-Yu Liu, Kai-Wen Hsiao, and Chao-Hsin Wu

*National Taiwan University, Taiwan***[P1-086]****A Symbolic Regression Derived Analytical Model Framework for Evaluating DIBL in Vertical GaN Fin-FETs**

Smriti Singh, Aasim Ashai, Ankita Mukherjee, Tanmoy Pramanik, and Biplab Sarkar

Indian Institute of Technology Roorkee, India



[P2] Poster Session 2

Session Date	Oct. 17(Thu.), 2024
Session Time	09:00-10:30
Session Room	Room C (Forum 1, 3F)

[P2-001]

Optimizing Normally-Off Operation of β -Ga₂O₃ Heterojunction Field Effect Transistors with p-NiO Integration for Improved Efficiency

Joonhui Park, Hanbit Kim, Sanghun Kim, Tajun Park, Yusup Jung, Taiyoung Kang, and Sinsu Kyoung
PowerCubeSemi Inc., Korea

[P2-002]

Improving Electrical Properties with NiO/ β -Ga₂O₃ Heterojunction Diode by Inserting Co-doped P-type Li-NiMgO Layer

Ho Jung Jeon and You Seung Rim
Sejong University, Korea

[P2-003]

Sn-Doped α -Ga₂O₃ Epitaxial Growth with Control Doping Concentration by Mist-CVD

Jang Hyeok Park¹, Jung Yeop Hong², Jung Hee Park², Young Kyun Jung², and You Seung Rim¹
¹*Sejong University, Korea*, ²*Hyundai Motor Group, Korea*

[P2-004]

Enhanced Thermal Management in Next-Generation Power Modules: A Computational Study on Wide Bandgap Semiconductors

G. Lee and B. Ma
Korea Electronics Technology Institute, Korea

[P2-006]

Structural Stability and Electronic Properties of (RhGa)₂O₃ and (RhAl)₂O₃ Alloys: A First-Principles Study

Kenta Matsubara, Toru Akiyama, and Takahiro Kawamura
Mie University, Japan

[P2-007]**Effect of Film Thickness on the Long Term Memory in the Multi-Wavelength Ga₂O₃-Based Optoelectronic Synapse Devices**

Hee-Jin Kim, Hye Jin Lee, Dabin Jeon, and Sung-Nam Lee
Tech University of Korea, Korea

[P2-008]**Wavelength-Dependent Optoelectronic Synaptic Properties in Ga₂O₃-Based Memcapacitors**

Hye Jin Lee, Seung Hun Lee, Dabin Jeon, Jeong-Hyeon Kim, and Sung-Nam Lee
Tech University of Korea, Korea

[P2-009]**Effect of Post-Annealing on Structural and Optical Properties of Mist-CVD Grown Amorphous Ga₂O₃ Thin Films**

Manami Miyazaki, Iori Yamasaki, Yuma Tanaka, Masatoshi Koyama, Akihiko Fujii, and Toshihiko Maemoto
Osaka Institute of Technology, Japan

[P2-010]**Low Temperature Growth of Amorphous Ga₂O₃ on C-plane Sapphire Substrates by Mist Chemical Vapor Deposition**

Iori Yamasaki, Manami Miyazaki, Yuma Tanaka, Masatoshi Koyama, Akihiko Fujii, and Toshihiko Maemoto
Osaka Institute of Technology, Japan

[P2-011]**Band Offsets and Interface Engineering of κ -Ga₂O₃/ α -Ga₂O₃ Hetero-Interface**

Chan Woong Kim, Ha Young Kang, Yoonho Choi, and Roy Byung Kyu Chung
Kyungpook National University, Korea

[P2-012]**Impact of Fluorine Dopant on the Growth and Phase Stability of κ -Ga₂O₃**

Ha Young Kang¹, Chan Woong Kim¹, Yoonho Choi¹, Minseok Choi², and Roy Byung Kyu Chung¹
¹*Kyungpook National University, Korea*, ²*Inha University, Korea*



[P2-013]

Shaping of β -Ga₂O₃ Crystal Ingot by Controlling Temperature Distribution in Edge-Defined Film-Fed Growth

Tae-Hun Gu^{1,2}, A-Ran Shin^{1,2}, Yun-Ji Shin¹, Seong-Min Jeong¹, Sung-Sik Lee², and Si-Young Bae³

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[P2-014]

Impurity Control in β -Ga₂O₃ Single Crystals Grown by EFG Method Using Pre-Melt and Post-Annealing

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[P2-015]

Investigation of Structural and Electrical Properties of F-Doped α -Ga₂O₃

Yoonho Choi, Chan Woong Kim, Ha Young Kang, and Roy Byung Kyu Chung

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Growth of β -Ga₂O₃ Single Crystal Under Ambient Conditions

Byeongcheol Choe, Sungkyun Park, and Jong Mok Ok

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[P2-017]

Investigation of Chemical Etching Features and Defects on (100) and (001) β -Ga₂O₃ Single Crystals Grown by EFG Method

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³Chungnam National University, Korea, ⁴Pukyong National University, Korea

[P2-019]

Properties of La-Doped Gallium Oxide Nanostructure by Electrospinning

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[P2-020]

Sn-Doped β -Ga₂O₃ Thin Films Grown on Off-Axis Sapphire Substrates by LPCVD Using Ga-Sn Alloy Solid Source

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[P2-022]

2kV-Class β -Ga₂O₃/4H-SiC Heterojunction Schottky Barrier Diode by Aerosol Deposition Method

Ji-Hyun Kim, Young-Hun Cho, Ji-Soo Choi, Geon-Hee Lee, and Sang-Mo Koo

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[P2-023]

High Performance Solar-Blind Deep UV Photodetectors based on Ga₂O₃/4H-SiC Heterojunction Diodes by Aerosol Deposition

Ji-Soo Choi, Ji-Hyun Kim, Seung-Hwan Chung, Geon-Hee Lee, and Sang-Mo Koo

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[P2-024]

Structural, Optical, and Electrical Characteristics of Metastable κ -Phase Ga₂O₃ Grown by MOCVD Using H₂O as an Oxygen Precursor

Dong Wook Lee, Yoon Jae Lee, and Honghyuk Kim

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[P2-025]

Atomistic Study of $\beta \rightarrow \gamma$ Phase Transformations in Ga₂O₃

Ru He and Flyura Djurabekova

University of Helsinki, Finland

[P2-026]

Characteristic of Amorphous Oxide-Based Thin Film Transistors Using Capping Layer

Jae-Sung Yoo, Tae-Kyun Moon, Sung-Yun Byun, and Kyoung-Kook Kim

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[P2-027]

High-Performance β -Ga₂O₃ Solar-Blind Photodetectors Grown by MOCVD with CF₄ Treatment

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[P2-029]

Effect of Adhesives at Initial Stage of Growth in SiC Single Crystal Grown by PVT Method

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[P2-030]

A Design of 1.2 kV SiC MOSFET with Split-Gate for Improvement of Breakdown Characteristics and HF-FOM

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[P2-031]

The Third Quadrant Curve Shifts of 4H-SiC SBD-Embedded MOSFETs

Wei-Tse Fu, Kung-Yen Lee, Pei-Chun Liao, Xue-Fen Hu, and Wei-Shan Zou

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[P2-032]

Influence of Oxidation Time and Method on 4H-SiC MOS Capacitor Characteristics

Young Jae Park, Seongjun Kim, Joon Kim, Hyeon Ju Hwang, Yu Jeong Lee, Kyeong Keun Choi, Woong-Suk Yang, Sung-Woong Han, Dae-Hwan Kang, and Hoon-Kyu Shin

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[P2-033]

Growth of SiC Single Crystals from Crushed CVD-SiC Block via Physical Vapor Transport Method

Ju-Hyeong Sun¹, Jae-Hyeon Park^{1,2}, Yun-Ji Shin¹, Si-Young Bae³, Won-Jae Lee⁴, and Seong-Min Jeong¹

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[P2-034]

Development of a Real-Time Simulator for Physical Vapor Transport of SiC by Machine Learning Techniques

Woon-Hyeon Jeong¹, Ga-Ae Ryu¹, Ju-Hyeong Sun¹, Jae-Hyeon Park^{1,2}, Yun-Ji Shin¹, Si Young Bae³, Sangil Hyun¹, and Seong-Min Jeong¹

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[P2-035]

Control of the Temperature Gradient in the Rapid Growth of Bulk SiC Crystals via the Physical Vapor Transport Method

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[P2-036]

Impact of Crystallographic Orientation and High-Temperature Bias Stress on 4H-SiC MOSFET Reliability

Min-Yeong Kim, Hyun-Woo Lee, Seung-Hwan Chung, and Sang-Mo Koo

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[P2-037]

Influence of the Temperature Gradient on the Defect Formation Mechanism in the Initial Stage of PVT Growth

Ju-Hyeong Sun¹, Jungwoo Choi², Myung-Ok Kyun², Shunta Harada³, Soon-Ku Hong⁴, Seong-Min Jeong¹, Si-Yeong Bae⁵, and Yun-Ji SHIN¹

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[P2-038]

Impact of the Chip Size on Reverse Recovery in SiC MOSFETs

Yeonjun Kim and Hyemin Kang

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[P2-039]

Effects of Parasitic Inductance on Current Spike in SiC MOSFETs

Taehyun Jang and Hyemin Kang

Korea Institute of Energy Technology, Korea

[P2-040]

Transport Mechanisms at TiAl Contact on P-type 4H-SiC for CMOS Application

Seongjun Kim, Young Jae Park, Woong-Suk Yang, Sung-Woong Han, Kyeong-Keun Choi, Dae-Hwan Kang, and Hoon-Kyu Shin

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[P2-041]

Hydrogen (H₂) Gas FET-Sensor based on Ta₂O₅ Film on SiC Substrate

Kyeong-Keun Choi and Sung-Kyu Kim

Pohang University of Science and Technology, Korea

[P2-042]

Investigation of Surface Morphology by Al Ion Implantation and High Temperature Post-Implantation Annealing on 4H-SiC under C-Cap

Sung-Woong Han, Seongjun Kim, Woong-Suk Yang, Kyeong-Keun Choi, Young Jae Park, Joon Kim, Dae-Hwan Kang, and Hoon-Kyu Shin

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[P2-043]

Effects of Electrical Field During Current Stress on Electrical Characteristics of SiO₂/4H-SiC MOSFETs

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[P2-044]

A TMBS Embedded 1.7 KV SiC UMOSFET

Jia-Wei Hu, Yi-Jie Wu, Chuan-Fu Lin, Kuan-Min Kang, and Chih-Fang Huang

National Tsing Hua University, Taiwan

[P2-045]

Effect of Annealing Temperature on The Properties of Ni/Ti/Au Ohmic Contacts on N-Type SiCJongbae Kang¹, Pyeung Hwi Choi^{2,3}, Sang-Hun Lee³, Seong-Ju Park¹, and Jae-Hyung Jang¹¹Korea Institute of Energy Technology, Korea, ²Samsung Electronics Co., Ltd., Korea, ³Gwangju Institute of Science and Technology, Korea

[P2-046]

Carbon Incorporation in MOCVD-Grown hBN and Its Optoelectronic Characteristics

Semi Im, Seokho Moon, and Jong Kyu Kim

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[P2-047]

Remote Moiré Engineering of Exciton Polarons in Monolayer MoSe₂ on Twisted hBNMinhyun Cho^{1,2}, Biswajit Datta², Kwanghee Han^{1,2}, Saroj B. Chand³, Pratap Chandra Adak², Sichao Yu², Kenji Watanabe⁴, Takashi Taniguchi⁴, James Hone⁵, Gabriele Grosso³, Vinod M. Menon², and Young Duck Kim¹¹Kyung Hee University, Korea, ²City College of New York, USA, ³City University of New York, USA, ⁴National Institute for Materials Science, Japan, ⁵Columbia University, USA

[P2-048]

Deep UV Photoluminescence Characterization of Pristine and Carbon Doped Hexagonal Boron NitrideSeung Tae Kim¹, Suk Hyun Kim¹, Kyungho Park¹, Minseong Kwon^{1,2}, Young Gie Lee^{1,2}, HeeYeon Lee¹, Kenji Watanabe³, Takashi Taniguchi³, and Young Duck Kim¹¹Kyung Hee University, Korea, ²Korea Institute of Science and Technology, Korea, ³National Institute for Materials Science, Japan

[P2-049]

Tunable Moiré Superlattice Potentials in Twisted Hexagonal Boron NitrideTaehyung Kim¹, Kwanghee Han¹, Minhyun Cho^{1,2}, Seung Tae Kim¹, Suk Hyun Kim¹, Sang Hwa Park³, Sang Mo Yang³, Kenji Watanabe⁴, Takashi Taniguchi⁴, Vinod Menon², and Young Duck Kim¹¹Kyung Hee University, Korea, ²City University of New York, USA, ³Sogang University, Korea, ⁴National Institute for Materials Science, Japan



[P2-050]

Localized Emission Control in hBN: Stable UV Color Centers via Electric Field

Kyeongho Park¹, Seungmin Park¹, Minseong Kwon^{1,2}, Suk Hyun Kim¹, Kenji Watanabe³, Takashi Taniguchi³, and Young Duck Kim¹

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[P2-051]

Transport Band Gap Measurement of Large-Area hBN by Using Direct and Inverse Photoemission Spectroscopy

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[P2-052]

Remote Modulation Doping via Hexagonal Boron Nitride Surface Engineering

Heeyeon Lee¹, Minseong Kwon^{1,2}, Kenji Watanabe³, Takashi Taniguchi³, Chaun Jang², and Young Duck Kim¹

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[P2-053]

High Electric Field Vertical Tunneling Transports in Hexagonal Boron Nitride

YoungJae Kim¹, Seungmin Park¹, Kenji Watanabe², Takashi Taniguchi², and Young Duck Kim^{1,2}

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[P2-054]

hBN-Based Photonic Crystal Cavities for Photonic Integrated Circuits

Sunjung An¹, Minhyun Cho¹, Junghyun Sung², Su Hyun Gong², Kenji Watanabe³, Takashi Taniguchi³, and Young Duck Kim¹

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[P2-055]

Transparent Neutron Shielding Layer based on Boron Nitride for Space Windows

Dobin Kim¹, Geunpil Kim¹, Hwi-Joon Jeong², Jinhwan Kim², Minjae Isaac Kwon³, Inkyu Park³, Jongbum Kim¹, and Jaehyun Park¹

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³University of Seoul, Korea

[P2-056]

Deep-Ultraviolet Electroluminescence in Van der Waals Heterostructures of Hexagonal Boron Nitride

Yerin Han^{1,2}, Sangho Yoon^{1,2}, Su-Beom Song^{1,2}, So Young Kim^{2,3}, Sera Yang^{1,2}, Seung-Young Seo^{1,2}, Soonyoung Cha^{1,2}, Kenji Watanabe³, Takashi Taniguchi³, Jun Sung Kim³, Moon-Ho Jo^{1,2}, and Jonghwan Kim^{1,2,3}

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[P2-057]

Electroluminescence from Isolated Color Centers in Hexagonal Boron Nitride

Gyuna Park^{1,2}, Ivan Zhigulin³, Hoyoung Jung^{1,2}, Jake Horder³, Karin Yamamura³, Yerin Han^{1,2}, Hyunje Cho^{1,2}, Hyeon-Woo Jeong², Kenji Watanabe⁴, Takashi Taniguchi⁴, Myungchul Oh^{1,2}, Gil-Ho Lee², Moon-Ho Jo^{1,2}, Igor Aharonovich³, and Jonghwan Kim^{1,2}

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[P2-058]

Enhanced Absorption in Hexagonal Boron Nitride via Fabry-Perot Resonance

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[P2-059]

Atomics Sawtooth-Like Metal Films for vdW-Layered Single-Crystal Growth

Hayoung Ko¹, Soo Ho Choi¹, Yunjae Park², Seungjin Lee¹, Chang Seok Oh¹, Sung Youb Kim², Young Hee Lee¹, Soo Min Kim³, Feng Ding^{1,4}, and Ki Kang Kim¹

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[P2-060]

Unveiling Borazine's Role in Temperature-Dependent hBN Growth on Ni Substrate

Jaewon Kim^{1,2}, Joo Song Lee¹, Yu Jin Kim¹, and Hyeon Suk Shin^{1,2}

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[P2-061]

Hexagonal Boron Nitride/Gallium Nitride Heterojunction for High-Performance Deep Ultraviolet Photodetection

Jawon Kim, Seokho Moon, and Jong Kyu Kim

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[P2-062]

Inducing Photoluminescence in Hexagonal Boron Nitride by Dichloromethane Treatment

Kyeongseo Cho¹, Duhee Yoon¹, Young Duck Kim², Dmitrii Litvinov³, Maciej Koperski³, and Hyeonsuk Shin¹

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[P2-063]

Synthesis of Thickness-Controllable Uniform Crystallized Hexagonal Boron Nitride for High-Performance Memristor

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[P2-064]

High Crystalline Quality Heteroepitaxial Diamond Growth Using Epitaxial Lateral Overgrowth

Yoonseok Nam¹, Taemyung Kwak¹, Geunho Yoo¹, Joocheol Jeong¹, Yeonghwa Kwon¹, Seong-Woo Kim², and Okhyun Nam¹

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[P2-065]

Heteroepitaxial Growth of Twin-Free Single Crystal (111) Diamond on R-Plane Al₂O₃ Substrate

Seolyoung Oh, Taemyung Kwak, Yeonghwa Kwon, Yoonseok Nam, Eonhee Roh, Geunho Yoo, and Okhyun Nam

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[P2-066]**High Power Boron-Doped Diamond Metal Semiconductor Field Effect Transistor Using Selective Grown P+ Layer**

Eonhee Roh¹, Taemyung Kwak¹, Seolyoung Oh¹, Yeonghwa Kwon¹, Yoonseok Nam¹, Geunho Yoo¹, Seongwoo Kim², and Okhyun Nam¹

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[P2-067]**Heteroepitaxial Diamond Grown on Compliant Substrate Using SOI Air-Void Structure**

Yeonghwa Kwon, Uiho Choi, Seolyoung Oh, Yoonseok Nam, Taemyung Kwak, Joocheol Jeong, Eonhee Roh, Geunho Yoo, and Okhyun Nam

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[P2-068]**Growth of Heteroepitaxial Diamond on 4H-SiC Single Crystals by Microwave Plasma Chemical Vapor Deposition**

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[P2-069]**Design of Substrate Holders for the Rapid Growth of Diamond via Microwave Plasma Chemical Vapor Deposition Method**

Nhat-Minh Phung^{1,2}, Ki-Yeol Woo^{1,3}, Gi-Ryeo Seong¹, Si-Young Bae³, Yun-Ji Shin¹, and Seong Min Jeong¹

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³Pukyong National University, Korea

[P2-070]**Joint Frequency-Temperature Analysis of High-Temperature Hopping Conduction in Heavily Boron-Doped Diamond**

Anna Solomnikova and Vasily Zubkov

St. Petersburg State Electrotechnical University, Russia



[P2-072]

Effect of Thermal Treatment on Long Term Memory Properties of ZnO Nanoparticles-Based Optoelectronic Synapse Devices

Dabin Jeon, Seung Hun Lee, Hye Jin Lee, Hee-Jin Kim, and Sung Nam Lee
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[P2-073]

Improvement of Long-Term Memory Characteristics of Carbon Nanotube Based Optoelectronic Synapse Devices Using Spin Coating Process

Seung Hun Lee, Jeong-Hyeon Kim, Hye Jin Lee, Dabin Jeon, Hee-Jin Kim, and Sung-Nam Lee
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[P2-074]

Super-Resolution Spectroscopy of Single-Photon-Level Emission

Michał Lipka, and Michał Parniak
University of Warsaw, Poland

[P2-075]

WO₃ Nanosheets Integrated Ti₃C₂ Heterojunctions with Synergistic Effects for Enhanced Water Splitting

Dong Jin Lee, Deuk Young Kim, and P. Ilanchezhian
Dongguk University, Korea

[P2-076]

Crystallization Kinetics of α -Aluminum Oxide on Graphene via Solid Phase Epitaxy

Jeongwoon Kim¹, Hyuk Jun Lee², Jongil Kim³, Jaeyoung Baik¹, Seoung Hyeok Lee¹, Jinsoo Kim¹, Hoe-Min Kwak⁴, Sangho Oh³, Young Jun Joo², and Dong-Seon Lee¹

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[P2-080]

Room-Temperature Operated NO₂ Gas Sensor of n-ZnO/p-Ag₂O Nanomaterials with UV Photon Energy

Jae-Hun Jeong, Jun-Young Lee, Sunwoo Lim, Yoojin Kim, and Kyoung-Kook Kim
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[P2-081]

Engineering of Nitrogen Delta-Doped Diamond NV Centers for Quantum Repeater Applications

Yong Soo Lee¹, Taemyung Kwak², Ye-Eun Choi¹, Chan-Gu Kang¹, Jaepil Park¹, Sang-Wook Han¹, Seungwoo Jeon¹, Chul-ki Kim¹, Junghyun Lee¹, Okhyun Nam², and Dongyeon Daniel Kang¹

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